Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	47	substrate and (((gate or scan$4) and (data or signal$4 or source)) near3 line) and ((thin near3 film near3 transistor) or tft) and (reflect$4 near3 (sheet or layer or film or plate)) and (transflect$4 or (transmiss$5 near4 (hole or area))) and (acrylic near4 resin) and ((silicon near3 (nitride or oxide))) and (pixel near3 electrode) and (capacitor or (capacit$5 near3 electrode)) and (amorphous near3 silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/12 09:37
S1	1830236	substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:18
S2	103289	((gate or scan$4) and (data or signal$4 or source)) near3 line	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:19
S3	67231	(thin near3 film near3 transistor) or tft	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:19
S4	184952	reflect$4 near3 (sheet or layer or film or plate)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:19
S5	35457	transflect$4 or (transmiss$5 near4 (hole or area))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:20
S6	105749	acrylic near4 resin	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:20
S7	235849	(silicon near3 (nitride or oxide))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:21

S8	32708	pixel near3 electrode	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:21
S9	613429	capacitor or (capacit$5 near3 electrode)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:23
S10	56005	amorphous near3 silicon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:24
S12	386	349/114	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:24
S13	1793	349/113	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:25
S14	22	(substrate and (((gate or scan$4) and (data or signal$4 or source)) near3 line) and ((thin near3 film near3 transistor) or tft) and (reflect$4 near3 (sheet or layer or film or plate)) and (transflect$4 or (transmiss$5 near4 (hole or area))) and (acrylic near4 resin) and ((silicon near3 (nitride or oxide))) and (pixel near3 electrode) and (capacitor or (capacit$5 near3 electrode)) and (amorphous near3 silicon)) and 349/113	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/09/15 10:25